WO 2005/006355 PCT/SE2004/000984

11

CLAIMS

15

20

25

30

35

- 1. A bushing for an electrical device, comprising an insulating core (1, 7, 9), characterized in that at least a part of the insulating core (1, 7, 9) comprises a continuous diffusion barrier (2, 8) with firm adhesion to the insulating core (1, 7, 9).
- 2. A bushing according to claim 1 characterized in that the diffusion barrier (2, 8, 11, 12) comprises a continuous film.
 - 3. A bushing according to claim 1 or 2, characterized in that the insulating core (1, 7, 9) is hollow and that at least part of the inside of the insulating core (1, 7, 9) is coated with the diffusion barrier (2, 8).
 - 4. A bushing according to any of the preceding claims, characterized in that the insulating core (1, 7, 9) comprises a body of epoxy resin impregnated paper.

5. A bushing according to any of the preceding claims, characterized in that an outer hollow insulator (10) is arranged outside the insulating core (1, 7, 9), and that at least a part of the outer hollow insulator (10) is coated with the diffusion barrier (11, 12).

- 6. A bushing according to any of the preceding claims, characterized in that essentially the whole surface of the outer hollow insulator (10) is coated with the diffusion barrier (11, 12).
- 7. A bushing according to any of the preceding claims, characterized in that the diffusion barrier (2, 8, 11, 12) comprises at least one of the following; an inorganic film, an organic film or an organic/inorganic hybrid film.

8. A bushing according to any of the preceding claims, characterized in that the diffusion barrier (2, 8, 11, 12) comprises a multi-layer film.

WO 2005/006355

35

- 9. A bushing according to any of the preceding claims, characterized in that the diffusion barrier (2, 8, 11, 12) comprises particles of hybrid or inorganic nature.
- 10. A bushing according to any of the preceding claims,
 10 characterized in that the diffusion barrier (2, 8, 11, 12) has
 a coefficient of water permeability smaller than
 0,1 g.m⁻².day⁻¹.
- 11. A bushing according to any of the preceding claims,

 15 characterized in that the diffusion barrier (2, 8, 11, 12) is

 deposited on at least part of the insulating core (1, 7, 9)

 and/or the outer hollow insulator (10) by one of the following

 methods; dipping, painting, spraying, plasma arc, sol-gel

 technology, Physical Vapor Deposition (PVD) or Chemical Vapor

 20 Deposition (CVD).
- 12. A method for manufacturing a bushing for an electrical device, the bushing comprising an insulating core (1, 7, 9), characterized in coating at least a part of the insulating core (1, 7, 9) with a continuous diffusion barrier (2, 8) with firm adhesion to the insulating core (1, 7, 9).
- 13. A method according to claim 12, characterized in coating at least a part of the insulating core (1, 7, 9) with a continuous film.
 - 14. A method according to any of claims 12-13, characterized in that the insulating core (1, 7, 9) is hollow, and in coating at least part of the inside of the insulating core (1, 7, 9) with the diffusion barrier (2, 8)

WO 2005/006355 PCT/SE2004/000984

13

15. A method according to any of claims 12-14, **characterized** in arranging an outer hollow insulator (10) outside the insulating core (1, 7, 9), and coating at least a part of the outer hollow insulator (10) with the diffusion barrier (11, 12).

5

10

20

- 16. A method according to any of claims 12-15, characterized in coating essentially the whole surface of the outer hollow insulator (10) with the diffusion barrier (11, 12).
- 17. A method according to any of claims 12-16, characterized in coating the insulating core (1, 7, 9) and/or the outer hollow insulator (10) with the diffusion barrier (2, 8, 11, 12) comprising at least one of the following; an inorganic film, an organic film or an organic/inorganic hybrid film.
 - 18. A method according to any of claims 12-17, characterized in coating the insulating core (1, 7, 9) with a diffusion barrier (2, 8, 11, 12) comprising a multi-layer film.
 - 19. A method according to any of claims 12-18, characterized in depositing the diffusion barrier (2, 8, 11, 12) on at least part of the insulating core (1, 7, 9) and/or the outer hollow insulator (10), by one of the following methods; painting, dipping spraying plasma are sol-gel technology. Physical
- 25 dipping, spraying, plasma arc, sol-gel technology, Physical Vapor Deposition (PVD) or Chemical Vapor Deposition (CVD).
- 20. Use of a bushing according to any of claims 1-11 in a medium voltage or high voltage electrical device, such as a transformer.
 - 21. Use of a bushing manufactured according to any of claims 12-19 in a medium voltage or high voltage electrical device, such as a transformer.